



# INSTYTUT TECHNOLOGII ELEKTRONOWEJ

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**INNOWACYJNA  
GOSPODARKA**  
NARODOWA STRATEGIA SPÓJNOŚCI

**UNIA EUROPEJSKA**  
EUROPEJSKI FUNDUSZ  
ROZWOJU REGIONALNEGO



DKZ/60/2009

Warsaw, 21.07.2009.

**Re: The open procedure for delivery of the system for dielectrics films deposition by sputtering technique.**

With regard to the following questions:

- 1. Is the customer interested to have their sputter system upgradable as their research changes over the next 3-5 years?*
- 2. Does the customer intend to run and fabricate optical films?*
- 3. Does the customer intend to use the system for pilot or R&D scale production?*

we inform that:

**Ad. 1**

The Awarding Entity doesn't expect the research changes over the next 3-5 years.

**Ad. 2**

The Awarding Entity will do AR and HR coating.

**Ad. 3**

The Awarding Entity doesn't exclude R&D scale production.

Zbigniew Poznański

  
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